



Speakers

Opening

Sunao Ishihara

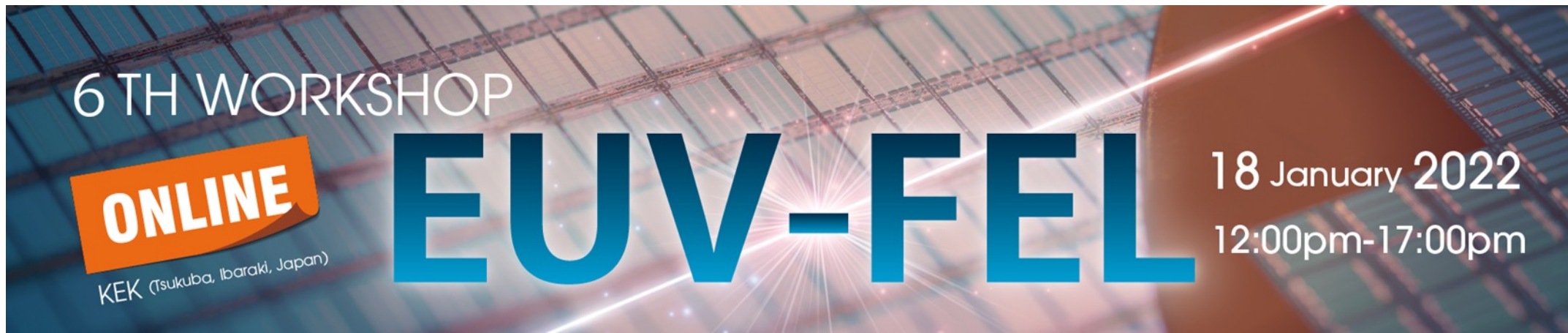
Key note lecturers **Tetsuro Higashi**
Atsuyoshi Koike

Invited speakers **Zhilong Pan**
Tsutomu Shoki
Hakaru Mizoguchi
Norio Nakamura

Closing address **Shin-ichi Adachi**

Session Chairs

Hidemi Ishiuchi
Masakazu Washio
Shinji Okazaki

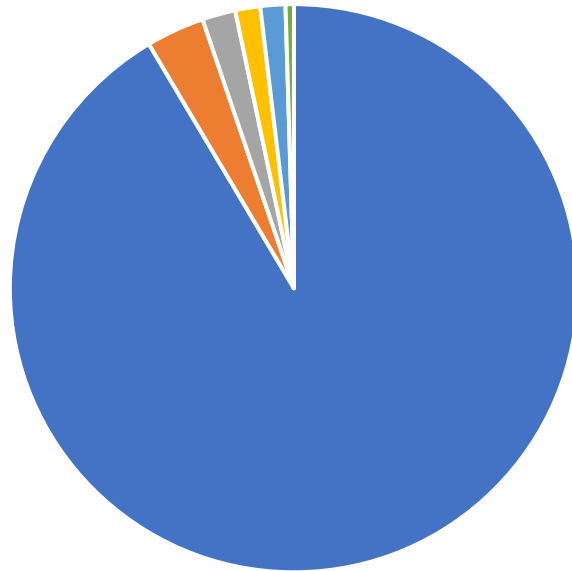


Participants

Number of registers; 211 @14/January/2022

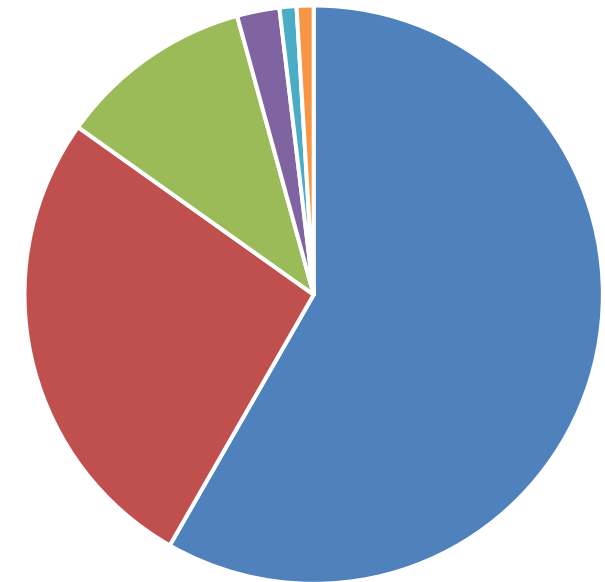
Country	Number
Japan	193
United States	7
Taiwan	4
Korea	3
Republic of China	3
Germany	1
Total	211

Country



Affiliation	Number
Company	123
Research institution	56
University	23
Consultant	5
Government agency	2
Other	2
Total	211

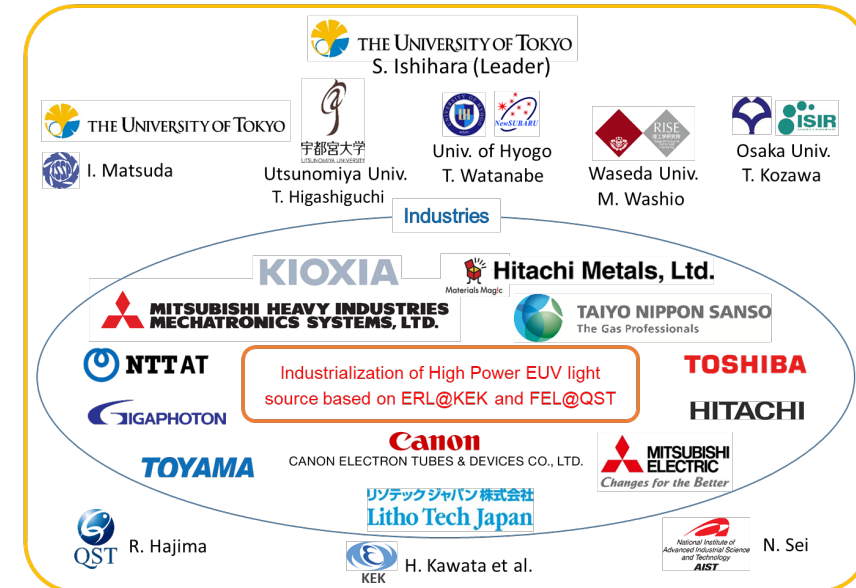
Affiliation





Organizers

EUV-FEL Light Source Study Group for Industrialization
High energy accelerator Research Organization (KEK) EUV-FEL Light Source Study Group for Industrialization
Center for Applied Superconducting Accelerator



Special Thanks

Workshop secretary; Hitomi Kusama

6TH WORKSHOP
ONLINE
KEK (Tsukuba, Ibaraki, Japan)

EUV-FEL

18 January 2022
12:00pm-17:00pm

*Photo-session
please turn on your camera
and make a smile.*

6TH WORKSHOP
ONLINE
KEK (Tsukuba, Ibaraki, Japan)

EUV-FEL

18 January 2022
12:00pm-17:00pm

Have a good day!
Good evening!
And good night!